

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q96338

Hitoshi ISHIZAKA, et al.

Appln. No.: 10/591,330

Group Art Unit: 1746

Confirmation No.: 9420

Examiner: Not yet determined

Filed: August 31, 2006

For: CLEANING MEMBER FOR SEMICONDUCTOR APPARATUS AND PROCESS FOR PRODUCING
THE SAME

**SUBMISSION OF ENGLISH TRANSLATION OF INTERNATIONAL PRELIMINARY
REPORT ON PATENTABILITY**

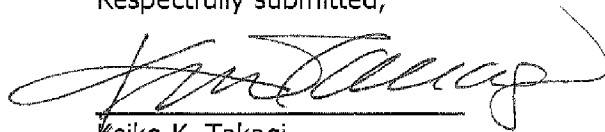
MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

For the Examiner's convenience, enclosed herewith is a copy of an English translation of the International Preliminary Report on Patentability received in reference to the above-identified application. It is noted that the four (4) references cited in the Report were previously listed on the PTO/SB/08 form submitted with the Information Disclosure Statement filed in the U.S. Patent and Trademark Office on August 31, 2006, along with copies of the foreign references.

Respectfully submitted,



Keiko K. Takagi
Registration No. 47,121

SUGHRUE MION, PLLC
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

WASHINGTON DC SUGHRUE/265550

65565

CUSTOMER NUMBER

Date: August 22, 2007